

Amendments to the Claims:

The following listing of claims will replace all prior versions, and listings, of claims in the application:

1. (Currently Amended) A pellicle for lithography which has at least, a pellicle film for dustproof protection, a pellicle frame to which the pellicle film is adhered, an adhesive layer provided on one end face of the pellicle frame in order to adhere the pellicle film, and a sticking layer formed on another end face of the pellicle frame, wherein the pellicle film is formed by a die coating ~~machine-machine~~, an area of the pellicle film is 1000 cm² or more, and a distribution of a thickness of the film in plane is within ± 10 %.

2. (Canceled)

3. (Currently Amended) ~~The~~ A lithographic process for manufacturing a liquid-crystal-display panel, comprising attaching the pellicle for lithography according to Claim 1 which is used in a lithography process for manufacture of a liquid crystal display panel to an exposure plate.

4.-21. (Canceled)